

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Kei HAYASAKI et al.) Group Art Unit: 1756
Application No.: 10/624,593) Examiner: Barreca, Nicole M.
Filed: July 23, 2003) Confirmation No. 7500
For: METHOD FOR FORMING A)
PATTERN AND SUBSTRATE	C-)
PROCESSING APPARATUS)

Mail Stop Amendment

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

AMENDMENT

This Amendment accompanies a Request for Continued Examination (RCE), and fulfills the requirement for a submission under 37 C.F.R. § 1.114. The Amendment is in reply to the Office Action mailed May 19, 2006, the period for response to which extends through August 21, 2006 (August 19th being a Saturday). Please amend the application as follows.

Amendments to the Claims are reflected in the listing of claims beginning on page 2 of this paper.

Remarks begin on page 29 of this paper.